



PATENT

Case Docket No. ASMINT.055AUS

Date: January 16, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Timmermans et al.
Appl. No. : 10/690,215
Filed : October 20, 2003
For : METHOD FOR THE
DEPOSITION OF SILICON
NITRIDE FILMS (As amended
herewith)
Examiner : Unknown
Group Art Unit : Unknown

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 20, 2004

(Date)

Adeel S. Akhtar, Reg. No. 41,394

TRANSMITTAL LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) Preliminary Amendment in 3 pages.
- (X) An Information Disclosure Statement in 1 page.
- (X) A PTO Form 1449 listing one (1) reference.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

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